

$$V04 = V01 - V02 \quad (\text{Expression 10})$$

$$= -(Cs/Cf) \cdot (R2/RI) \cdot (Vin/A)$$

[0061] Accordingly, the voltage V04 of the detection signal output from the output terminal 24 of this electrostatic capacitance detection circuit 30 is in proportion to the capacitance value Cs. Therefore, unknown capacitance value Cs and a fluctuation in the capacitance can be easily specified by executing various signal processing based on this voltage V04.

[0062] As clarified from comparison between this expression 10 and the expression 5 that indicates the voltage Vout of the detection signal according to the first embodiment, unlike the first embodiment 30, the detection signal obtained by the electrostatic capacitance detection circuit 30 according to the second embodiment contains only a component being in proportion to the capacitance of the capacitor 17, and does not contain any unnecessary offset (i.e. the voltage that does not depend on the capacitor 17). Therefore, signal processing according to the second embodiment, which specifies capacitance or a fluctuation in the capacitance of the capacitor 17 from the detection signal, can be simple.

[0063] Although a case of V03=-V01 is used in this example, the present invention is not limited to this. According to a type of the capacitive sensor, the output voltage V04 can be set as follows with a case of V03=k·V01 (k is an amplification ratio of an inverting amplification unit).

$$V04 = \{k \cdot (Cs/Cf) + (k+1)\} \cdot (R2/RI) \cdot Vin$$

[0064] FIG. 5 is a diagram showing a practical example to use the electrostatic capacitance detection circuit according to the first and second embodiments for an electric device. Here, it shows a cross section diagram of a microphone 50 used for a mobile phone or the like which comprises a capacitor microphone and an electrostatic capacitance detection circuit that are integrated into one. This microphone 50 comprises a lid cover 51 having a sound hole 52, an oscillating film 53 that oscillates with sounds, a ring 54 that fixes the oscillating film 53, a spacer 55a, a fixed electrode 56 set up against the oscillating film 53 via the spacer 55a, an isolation board 55b that supports the fixed electrode 56, an IC chip 58 forming the electrostatic capacitance detection circuit according to the above embodiment, which is fixed on a backside of the isolation board 55b, an IC package 59 that molds the IC chip 58, external electrodes 61a and 61b that are connected by the IC chip 58, a wire bonding or the like.

[0065] The oscillating film 53, which is one side of the electrodes that forms the capacitor, is connected to specific potential (a ground in this example), and the fixed electrode 56, which is the other side of the electrodes, is connected to a circuit of the IC chip 58 via an electric conductor such as an aluminum board, a wire bonding, or a contact hole. Capacitance and a change in the capacitance of the capacitor comprising the oscillating film 53 and the fixed electrode 56 are detected by the electrostatic capacitance detection circuit in the IC chip 58 located adjacently via the isolation board 55b, transformed into an electric signal, and output from the external electrodes 61a and 61b, or the like. The lid cover

51, which is made from a metal such as aluminum, serves as a role of a shield box that shields any disturbance noise mixed into the inner capacitors 53 and 56, and the IC chip 58 with a conductive film (not shown) formed on an upper surface of the isolation board 60. In this example, the fixed electrode 56 is connected to the circuit, and the oscillating film 53 is connected to specific potential. However, the oscillating film 53 may be connected to the circuit, and the fixed electrode 56 may be connected to the specific potential. But, the former case is preferable from past experiences.

[0066] FIG. 6 is an external view diagram showing an outline of the microphone 50 shown in FIG. 5. FIG. 6A is a plain view, FIG. 6B is a front view, and FIG. 6C is a bottom view diagram. Size of the lid cover 51 shown in FIG. 6A and FIG. 6B is, for example, approximately $\phi 5$ mm in diameter $\times 2$ mm in height. Four external electrodes 61a-61d shown in FIG. 6C are, for example, two terminals for a power supply and two terminals for an output signal of the electrostatic capacitance detection circuit.

[0067] In such a practical example, the capacitor to be detected (the capacitor microphone in the example here) and the electrostatic capacitance detection circuit (the IC chip in the example here) are located adjacently, the signal line is extremely short, and the stray capacitance thereof is connected by an electric conductor of which length does not exceed ten times as much as a bigger capacitance value of either the capacitor microphone or the first impedance element in the circuit. Then, these parts are covered with a shield material such as a metal lid cover. Therefore, in the practical example like this, any negative impacts such as disturbance noise, which is mixed into the signal line (the electric conductor) connecting the capacitor to be detected and the electrostatic capacitance detection circuit, can be ignored.

[0068] That is, in a compact microphone like this, since the capacitor to be detected and the electrostatic capacitance detection circuit are connected each other by an extremely short electric conductor, connecting them by a shield cable and using a special circuit for applying guard voltage to the shield make the size of the circuit rather bigger and impede miniaturization of the circuit. Therefore, it is preferable that the capacitor to be detected and the electrostatic capacitance detection circuit are connected by a non-shielded (unshielded) conductive board, wiring pattern, wire bonding, lead line or the like through a shortest route. As other example of the microphone, FIG. 7 and FIG. 8 show the circuit put on a board. It is basically the same as the example according to the above embodiment with the exception of the electrostatic capacitance detection circuit put on a board 62.

[0069] Although the electrostatic capacitance detection circuit according to the present invention has been described based on the two embodiments and the practical examples applied to a product, the present invention is not limited to these embodiments and practical examples.

[0070] For instance, in the electrostatic capacitance detection circuits 10 and 30, the capacitor 15 is connected between the operational amplifier 14 and the impedance converter 16 to detect electric current flowing through the capacitor 17, but an impedance element such as a resistance or an inductance may be connected.

[0071] Also, as shown in FIG. 9, it is possible to connect a resistance 18 in parallel with the capacitor 15 in the